

Please Direct All Correspondence to Customer Number **20995****TRANSMITTAL LETTER
INFORMATION DISCLOSURE STATEMENT**

Applicant : Naoto TSUJI, et al.
App. No : 10/657,416
Filed : September 8, 2003
For : INTERLAYER INSULATION FILM
USED FOR MULTILAYER
INTERCONNECT OF
SEMICONDUCTOR INTEGRATED
CIRCUIT AND METHOD OF
MANUFACTURING THE SAME
Examiner : William C. Vesperman
Art Unit : 2813

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

June 17, 2005

(Date)

Katsuhiro Arai, Reg. No. 43,315

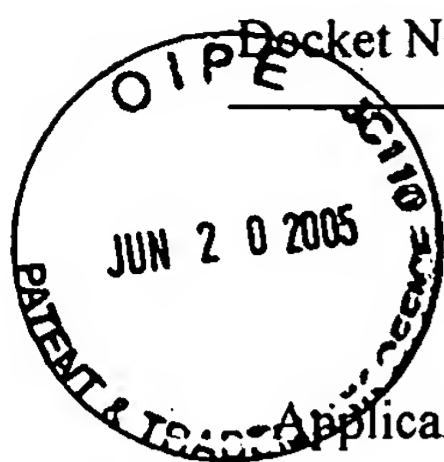
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement and PTO/SB/08 equivalent listing references for consideration:
 - (X) Listing nine (9) references.
 - (X) Enclosing five (5) references.
- (X) A copy of the communication issued by the European Patent Office.
- (X) The Commissioner is hereby authorized to charge any fees which may be required to Account No. 11-1410.
- (X) Return prepaid postcard.

Katsuhiro Arai
Registration No. 43,315
Attorney of Record
Customer No. 20,995
(949) 760-0404



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Mail Stop Amendment
Commissioner for Patents
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Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing nine (9) references to be considered by the Examiner. Also enclosed are five (5) foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing date of a Notice of Allowance.

CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(1)

I hereby certify that each item of information contained in this Statement was first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than 30 days prior to the filing of this Information Disclosure Statement.

Thus, no fee is required as set forth in 37 C.F.R. § 1.97(c).

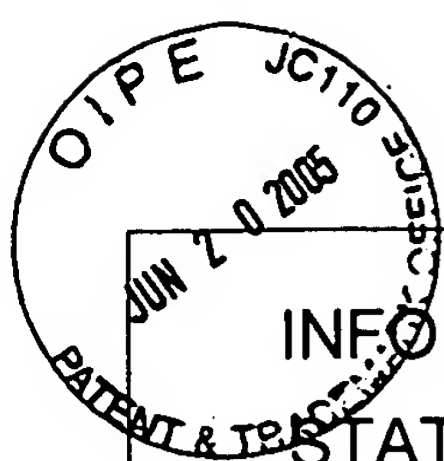
Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: June 17, 2005

By:

Katsuhiro Arai
Registration No. 43,315
Attorney of Record
Customer No. 20,995
(949) 760-0404

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

<i>(Multiple sheets used when necessary)</i>	Application No.	10/657,416
	Filing Date	September 8, 2003
	First Named Inventor	Naoto TSUJI, et al.
	Art Unit	2813
SHEET 1 OF 1	Examiner	William C. Vesperman
	Attorney Docket No.	ASMJP.134AUS

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1.	6,374,770 B1	04/23/2002	Peter W. LEE, et al.	
	2.	6,383,917 B1	05/07/2002	Neal J. COX	
	3.	2002/0106891A1	08/08/2002	Jae-Hak KIM, et al.	
	4.	2003/042605 A1	03/06/2003	Ebrahim ANDIDEH, et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	5.	WO 99/55526 A	11/04/1999	Peter ROSE, et al.		
	6.	EP 1 122 770 A2	08/08/2001	Atsushi SHIOTA, et al.		
	7.	EP 1 148 539 A2	10/24/2001	Tzu-Fang HUANG, et al.		
	8.	EP 1 201 795 A1	05/02/2002	Srinivas D. NEMANI, et al.		

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	9.	Hean Ju LEE, et al., "The mechanical properties of the SiOC(-H) composite thin films with a low dielectric constant" SURFACE & COATING TECHNOLOGY, JOINT INTERNATIONAL PLASMA SYMPOSIUM OF THE 6 TH ASIA-PACIFIC CONFERENCE ON PLASMA SCIENCE & TECHNOLOGY, JEJU ISLAND, SOUTH KOREA, vol. 171 no. 1-3, July 1, 2002- July 4, 2002, ELSEVIER, SWITZERLAND, pages 296, 300	

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Examiner Signature	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

T¹ - Place a check mark in this area when an English language Translation is attached.